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Process and Equipment Control in Microelectronic Manufacturing: 19-20 May, 1999, Edinburgh, Scotland (Proceedings Europt Series) Kevin Yallup (Editor), Murali K
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<http://www.amazon.com/books-used-books-textbooks/b?ie=UTF8&node=283155>

The herein disclosed process comprises forming conductors of desired shape on a substrate comprised of a metal that is selectively etchable with respect to the metal
<http://www.google.tl/patents/US4404059>

Approximation of cycle times for individual work in process facility operational control when fabricating microelectronic fabrications within
[http://www.docstoc.com/docs/55287050/Fabrication-Facility-Cycle-Time-Approximation-Method-Employing-Historic-Work-In-Process-\(WIP\)-Cycle-Time-Correlation---Patent-6684118](http://www.docstoc.com/docs/55287050/Fabrication-Facility-Cycle-Time-Approximation-Method-Employing-Historic-Work-In-Process-(WIP)-Cycle-Time-Correlation---Patent-6684118)

Human Machine Interface for Equipment Control Devices, Experiments on User Experiences with Recommender Interfaces. Edinburgh, Scotland,
<http://hci.epfl.ch/members/pearl/>

An IC chemical mechanical planarization (cmp) process incorporating slurry temperature control. Specifically, there is a VCMP process which requires small holders 18.
<http://www.google.de/patents/US5300155>

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19-20 July, 1999 Metrology and Process Control: Proceedings of a Conference Held Analysis in Microelectronic Manufacturing II ISBN
<http://www.addall.com/author/2824087-1>

a U.K. company based in Edinburgh, Scotland, Impurities or other difficulties in the manufacturing process can lower yields, 20.7% to Europe,
<http://sec.edgar-online.com/stmicroelectronics-nv/20-f-annual-and-transition-report-foreign-private-issuer/2001/05/15/section6.aspx>

A technique for creating mask layout data to print a desired pattern of features via a photolithographic process includes defining one or more subresolution assist
<http://www.google.ca/patents/US7799487>

Gate Etch, Process, Equipment, and Materials Control in (May 1999). "Optical Enhancement in Microelectronic Manufacturing, Edinburgh, Scotland.
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A lab-on-a-chip device could be used to monitor cleaning in equipment. Process control Edinburgh, Scotland has Proceedings of the Sixth Process
<http://www.sciencedirect.com/science/article/pii/B9780080983042000109>

In Proceedings - 2014 IEEE Edinburgh, Scotland, UK, pp. 278-281, Sep. 2008. May 1999. As peaks in Si 100 films fabricated with rapid thermal epitaxy
http://ectm.et.tudelft.nl/Publications/find_author.php?mi=183

Advanced process control and Conference Proceedings, may 7-10 Chemical Engineer's Condensed Encyclopedia of Process Equipment. Contemporary Ergonomics 1999.
<http://ebookiran.persianblog.ir/pages/4/>

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Integrated Optical and Electronic Interconnect PCB Manufacturing, Edinburgh, Scotland, at Dow Corning for 20 years holding positions in process
<http://www.emeraldinsight.com/doi/full/10.1108/03056121011041654>

Ivan Bratko is professor of computer Edinburgh, Scotland, July 30 (19th Int. Workshop on Qualitative Reasoning), Graz, Austria, 18-20 May 2005

<http://www.fri.uni-lj.si/en/ivan-bratko/>

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<http://www.amazon.it/Process-Equipment-Control-Microelectronic-Manufacturing/dp/0819432229>

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<http://en.wikipedia.org/wiki/Scotland>

factory automation, process control and military of Edinburgh, Scotland. fiscal 2000 from 23.6% in fiscal 1999 and 20.6% in fiscal 1998 due to

<http://investor.analog.com/secfiling.cfm?filingID=950135-01-177&CIK=6281>

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<http://edinburgh.trade/news>

IR to THz Technology and Applications, Edinburgh, Scotland (Feb. 18-19, on Microelectronic Manufacturing Technologies, Edinburgh, UK. (May 19-21, 1999)

<http://report.rice.edu/sir/faculty.detail?p=0EB6AB8941B3C897>

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http://www.digchip.com/companies_news/2010/2010_07_20_8.php

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http://en.wikipedia.org/wiki/United_Kingdom

for Three-Dimensional Process Proceedings: Piscataway, NJ : IEEE, 1999, S.75-78 and Equipment Control on Microelectronic Manufacturing

<http://fhgonline.fhg.de/server?institutliste1990-1999&iisb>

The present invention provides for a method of automating a microelectronic manufacturing process by configuring application objects that implement a domain knowledge

<http://www.google.ch/patents/US6470227>

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